

## REMARKS

Applicants appreciate the Examiner's allowance of Claims 1-6, 19-24 and 29.

Applicants will now address the Examiner's remaining rejection.

### Claim Rejections - 35 USC §103

In the Final Rejection, the Examiner rejects Claims 7-10, 25-28 and 30-33 under 35 USC §103(a) as being unpatentable over Tsukabi et al. (US 6,696,096) in view of Van Slyke et al. (US publication no. 2003/0015140 A1), Utsugi et al. (US 6,294,892), Terasaka et al. (US 4,897,290) and Smith (US 6,830,626). This rejection is respectfully traversed.

More specifically, the Examiner contends that Tsubaki discloses the invention substantially as claimed and then proceeds to cite Van Slyke, Utsugi, Terasaka and Smith for all the claimed features not shown in Tsubaki and contends that it would have been obvious for one skilled in the art to combine all these references to arrive at the claimed invention. For example, the Examiner contends that "[i]t would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a side of a substrate set at an oblique angle with respect to an evaporation source...in Tsubaki et al., Van Slyke et al. and Utsugi et al. in order to form a layer having uniform alignment angles at high precision in the direction in which the uniform evaporation depositing on the substrate surface will be required as taught by Terasaka et al." Applicants respectfully disagree.

While Applicants disagree with the Examiner's analysis and contentions and traverse this rejection, in order to advance the prosecution of this application, Applicants are amending independent Claims 7, 9, 25 and 27 to recite a moving mechanism for moving said evaporation source holder during the evaporation of an evaporation material.

In contrast, neither Tsubaki nor Van Slyke (or the other cited references) disclose or suggest that a moving mechanism for moving the evaporation during evaporation of an evaporation material. Further, while Terasaka appears to disclose setting a longitudinal direction of an evaporation source at an oblique angle to a side of a substrate in an x-direction or a y-direction of a substrate, Terasaka does not disclose or suggest a moving mechanism for moving the evaporation sources holder during evaporation of an evaporation material.

Applicants have also amended independent Claim 32 to recite wherein the containers of the evaporation source holder include at least some containers set obliquely to the surface of the substrate at a different angle. This feature is supported by, for example, Fig. 19B of the present application. This feature is also not shown by the cited references.

Accordingly, the cited references do not disclose or suggest the claimed invention, and the claims are patentable thereover. Therefore, it is respectfully requested that this rejection be withdrawn.

#### Information Disclosure Statement

Applicants are filing an information disclosure statement (IDS) herewith. As a RCE is being filed herewith, it is respectfully requested that the Examiner enter and consider this IDS prior to the issuance of any further action on this application.

#### Conclusion

Accordingly, it is respectfully submitted that the present application is in a condition for allowance and should be allowed.

If any further fee is due for this amendment or the submissions herewith, please charge our deposit account 50/1039.

Favorable reconsideration is earnestly solicited.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Mark J. Murphy", is written over a horizontal line.

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